



PATENT APPLICATION
Q62494

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

In re application of

Ryo KUBOTO, *et al.*

Appln. No.: 09/817,233

Group Art Unit: 2823

Confirmation No.: 8072

Examiner: Hsien Ming LEE

Filed: March 27, 2001

For: MANUFACTURING METHOD OF SEMICONDUCTOR
DEVICE HAVING DRAM CAPACITORS

AMENDMENT UNDER 37 C.F.R. §1.111

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 29, 2004, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS	2
REMARKS	10